



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tadahiro OHMI et al.

Serial No.: 09/864,376

Filing Date: May 25, 2001

For: PLASMA PROCESSING  
APPARATUS AND PLASMA  
PROCESSING METHOD

Customer No. 004372

Confirmation No.: 1605

Art Unit: 1763

Examiner: Rudy ZERVIGON

Docket No.: 107176-00007

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

July 11, 2005

Sir:

Applicants petition for an extension of time for one-month for response to the outstanding Office Action dated March 11, 2005 from June 11, 2005 to July 11, 2005. Attached is our check in the amount of \$120.00.

The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300, referencing docket number 107176-00007.

Respectfully submitted,

  
Sam Huang  
Registration No. 48,430

AREN'T FOX PLLC  
1050 Connecticut Avenue, N.W.,  
Suite 400  
Washington, D.C. 20036-5339  
Tel: (202) 857-6000  
Fax: (202) 638-4810

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